

<b>Notice of References Cited</b>	Application/Control No. 10/828,489	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Adam L. Basehoar	Art Unit 2178	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0210428	11-2003	Bevlin et al.	358/1.18
*	B	US-5,995,985	11-1999	Cai, Yunming	715/507
*	C	US-6,851,087	02-2005	Sibert, Mark A.	715/505
*	D	US-6,662,340	12-2003	Rawat et al.	715/507
*	E	US-5,704,029	12-1997	Wright, Jr., Gerald V.	715/505
*	F	US-6,336,124	01-2002	Alam et al.	715/523
*	G	US-6,078,403	06-2000	Palmer, Dwight Ross	358/1.18
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.